



Sheet 1 of 1

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| U.S. Department of Commerce, Patent and Trademark Office | | Serial No.: 10/010,786 |
| | | Filing Date: 11/09/2001 |
| SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT | | Inventors: Novotny, et al. |
| "MICRO-ELECTRO-MECHANICAL VARIABLE OPTICAL ATTENUATOR" | | Group Art Unit: 2874 |
| | | Examiner Name: Valencia, Daniel E. |
| | | Attorney Docket No.: 13441-002001 (AO-777) |

U.S. Patent Documents

| *Examiner Initial | | Document Number | Date | Name | Class | Subclass | Filing Date, If Appropriate |
|-------------------|----|-----------------|------|------|-------|----------|-----------------------------|
| | AA | | | | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |

Foreign Patent Documents

| | | | | | | Translation | |
|--|-----------------|------|---------|-------|----------|-------------|----|
| | Document Number | Date | Country | Class | Subclass | Yes | No |
| | AF | | | | | | |

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

| | | |
|------------|----|---|
| <i>JDL</i> | AG | US 2002/0005976 A1, Publication date: January 17, 2002. "Multi-Layer, Self-Aligned Vertical Combdive Electrostatic Actuators and Fabrication Methods." Inventors: Behrang Behin and Satinderpall Pannu. Filed March 14, 2001. Application Number: 09/810,333. |
| <i>JDL</i> | AH | US 2002/0172452 A1, Publication date: November 21, 2002. "Latching Apparatus for a MEMS Optical Switch." Inventors: Nan Zhang, Hong Zhang, and Gary Nault. Filed May 18, 2001. Application Number: 09/860,300. |
| | AI | |
| | AJ | |

Examiner *John D. Lee* Date Considered *04 March 2004*

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.